PATENT



Application No.:

10/674,292

Filing Date:

September 29, 2003

Applicant:

Hironori Hasei et al.

Group Art Unit:

1734

Examiner:

Yewebdar T. Tadesse

Title:

METHOD FOR FORMING THIN FILM PATTERN, THIN FILM MANUFACTURING DEVICE, CONDUCTIVE THIN FILM WIRING, ELECTRO-OPTIC DEVICE, ELECTRONIC APPARATUS, AND

NON-CONTACT CARD MEDIUM

Attorney Docket:

9319G-000567

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

In response to the Office Action mailed <u>December 22, 2004</u>, please amend the application as follows and consider the remarks set forth below.

Applicant hereby petitions under the provisions of 37 C.F.R. § 1.136(a) for an extension of time in which to respond to the outstanding Office Action and includes a fee as set forth in 37 C.F.R. § 1.17(a) with this response for such extension of time.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 3 of this paper.